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520.39737X00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: OTSUBO et al

Serial No.: 09/842,000

Filed: April 26, 2001

For: Plasma Processing Apparatus and Processing Method

Art Unit: 1763

Examiner: A. Crowell

AMENDMENT

Mail Stop: Amendment (No Fee)
Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

September 30, 2005

Sir:

The following amendments and remarks are respectfully submitted in connection with the above-identified application, in response to the Office Action dated June 30, 2005. The amendments are listed below and set forth on the following pages.

Amendments to the Claims; and

Remarks are included following the amendments.